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(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hironori Ibusuki

Art Unit: 1756

Application No.: 10/780,667

Conf. No. 1986

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For: EXPOSURE PATTERN OR MASK AND

INSPECTION METHOD AND

MANUFACTURE METHOD FOR THE SAME

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Dear Sir:

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Respectfully submitted,

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